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Applicant(s):

Juergen WEISSER, Stefan ACKER and Ronny ULLMANN

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Exam. Init		Document Number	Date	Name	Class	Sub- Class	Filing Date Appropriate
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		 Date.	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.